

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S2	5803	oxidation?resist\$3 or oxidation adj resist\$3	US-PGPUB; USPAT	OR	OFF	2004/12/18 20:45
S3	168344	alumina\$1	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12
S4	64211	aluminum adj oxide	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S5	16178	"Al.sub.2O.sub.3"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S6	83885	silicon adj nitride	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S7	6279	"Si.sub.3N.sub.4"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S8	383	"Si.sub.xN.sub.y"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S9	2	"Si.sub.yN.sub.x"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S10	101	SixNy	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S11	1034	Si3N4	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:14
S12	286014	capacitor\$1	US-PGPUB; USPAT	OR	OFF	2004/12/18 20:41
S13	10	S12 and (S2 same (S3 or S4 or S5) same (S6 or S7 or S8 or S9 or S10 or S11))	US-PGPUB; USPAT	OR	OFF	2004/12/18 20:52
S14	3579	oxidation?resist\$3 or oxidation adj resist\$3	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:45
S15	108583	alumina\$1	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:46
S16	11329	aluminum adj oxide	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:46
S17	0	"Al.sub.2O.sub.3"	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:47
S18	0	"AlO.sub.3"	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:47
S19	0	"Al.sub.2O.sub.3"	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:47

S20	38520	silicon adj nitride	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:47
S21	56979	Al2O3	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:48
S22	8705	Si3N4	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:48
S23	69	SixNy	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:48
S24	2	SiyNx	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:48
S25	315748	capacitor\$1	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 20:48
S26	0	S14 and (S15 or S16 or S21) and (S20 or S22 or S23 or S24) and S25	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 21:30
S27	10	S12 and (S2 same (S3 or S4 or S5)) and (S2 same (S6 or S7 or S8 or S9 or S10 or S11))	US-PGPUB; USPAT	OR	OFF	2004/12/18 20:51
S28	1202	oxidation adj barrier	US-PGPUB; USPAT	OR	OFF	2004/12/18 21:29
S29	5153	oxygen adj2 barrier	US-PGPUB; USPAT	OR	OFF	2004/12/18 20:51
S30	33	S12 and ((S28 or S29) same (S3 or S4 or S5) same (S6 or S7 or S8 or S9 or S10 or S11))	US-PGPUB; USPAT	OR	OFF	2004/12/18 21:34
S32	214	oxidation adj barrier	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 21:29
S33	2452	oxygen adj barrier	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 21:29
S34	3188	oxygen adj2 barrier	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 21:29
S35	3	(S15 or S16 or S21) and (S20 or S22 or S23 or S24) and S25 and (S32 or S33 or S34)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/12/18 21:30
S36	47	(S28 or S29) same (S3 or S4 or S5) same (S6 or S7 or S8 or S9 or S10 or S11)	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:11
S37	443609	oxygen	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12

S38	9237	O2	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12
S39	128586	"O.sub.2"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12
S40	6830	barrier near2 (S37 or S38 or S39)	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12
S41	168344	alumina\$1	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:12
S42	64211	aluminum adj oxide	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S43	16178	"Al.sub.2O.sub.3"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S44	12	AlO3	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S45	1387	Al2O3	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S46	83885	silicon adj nitride	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S47	6279	"Si.sub.3N.sub.4"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S48	383	"Si.sub.xN.sub.y"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S49	2	"Si.sub.yN.sub.x"	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:13
S50	101	SixNy	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:14
S51	1034	Si3N4	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:14
S52	286014	capacitor\$1	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:14
S53	24	(S40 same (S41 or S42 or S43 or S44 or S45) same (S46 or S47 or S48 or S49 or S50 or S51)) and S52	US-PGPUB; USPAT	OR	OFF	2004/12/18 22:25
S55	72	(S40 same (S41 or S42 or S43 or S44 or S45)) and S52	US-PGPUB; USPAT	OR	OFF	2004/12/18 23:13
S56	2220	atomic adj layer\$2 adj deposit\$3	US-PGPUB; USPAT	OR	OFF	2004/12/18 23:14
S57	335	S56 same (S41 or S42 or S43 or S44 or S45)	US-PGPUB; USPAT	OR	OFF	2004/12/18 23:15